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FIG.1A

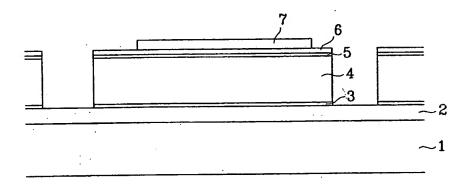
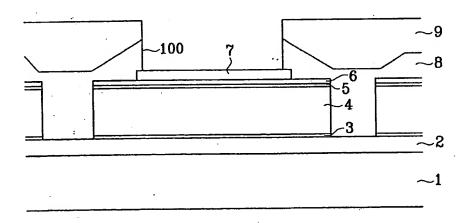


FIG.1B



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FIG.1C

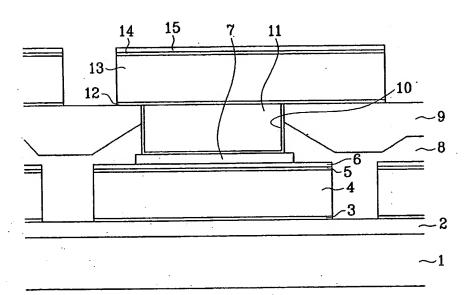
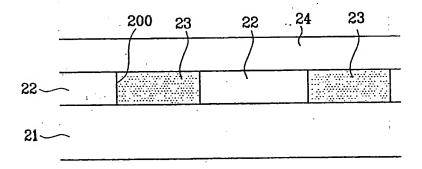


FIG.2A



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FIG.2B

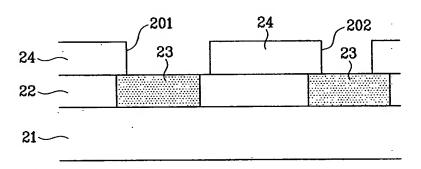


FIG.2C

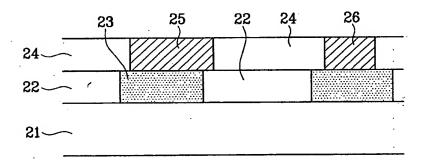
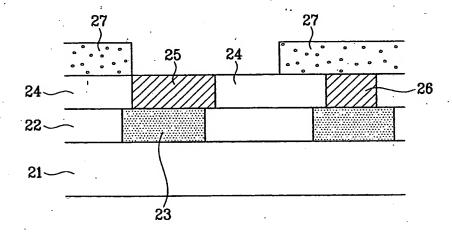


FIG.2D



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FIG.2E

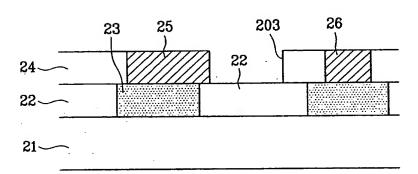


FIG.2F

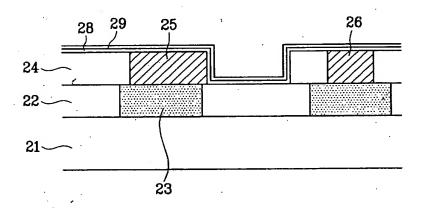
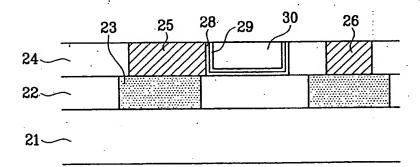


FIG.2G



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FIG.2H

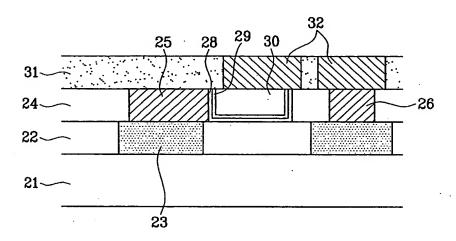


FIG.3A

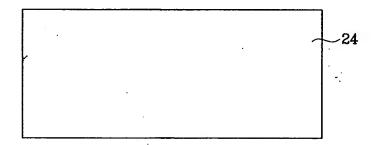
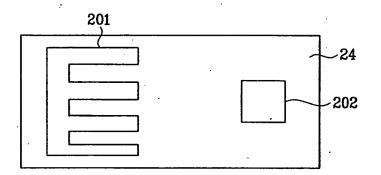


FIG.3B.



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FIG.3C

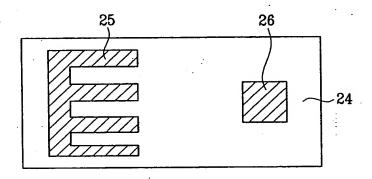


FIG.3D

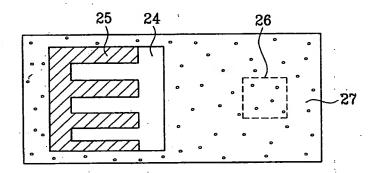
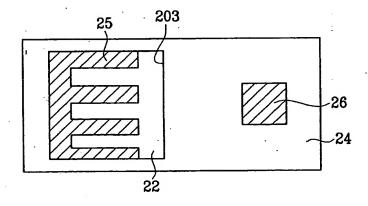


FIG.3E



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FIG.3F

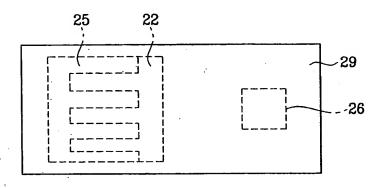


FIG.3G

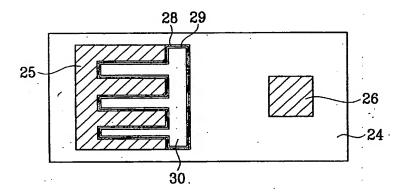


FIG.3H

